

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. <b>07977-103003</b>	Application No. <b>10/811,920</b>
	Applicant <b>Hongyong Zhang</b>		
	Filing Date <b>March 30, 2004</b>	Group Art Unit <b>2871</b>	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
<i>2000</i>	AL	JP63-104025	09 MAY 1988	JAPAN			Abstract	
<i>↓</i>	AM	JP03-163418	15 JUL 1991	JAPAN			Abstract	
<i>↓</i>	AN	JP06-289413	18 OCT 1994	JAPAN			Abstract	
<i>↓</i>	AO	JP07-092477	07 APR 1995	JAPAN			Abstract	
<i>↓</i>	AP	JP09-179130	11 JUL 1997	JAPAN			Abstract	

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
<i>2000</i>	AQ	Memorandum & Order re: Claim Construction, Semiconductor Energy Laboratory Co., Ltd., Plaintiff vs. Chi Mei Optoelectronics Corp., et al., Defendants, No. C04-04675 MHP, dated March 24, 2006, 41 pages.
	AR	
	AS	
	AT	

Examiner Signature <i>Mike Q.</i>	Date Considered <i>12-11-06</i>
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	